

Docket No.: 8733.428.00-US

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yong-In Park, et al.

Application No.: 09/855,694

Filed: May 16, 2001

For: METHOD OF FABRICATING A THIN FILM TRANSISTOR AND MANUFACTURING

EQUIPMENT

Group Art Unit: 2823

Examiner: J. Maldonado

RECEIVED
SEP 23 2002
TECHNOLOGY CENTER 2800

## REQUEST FOR EXAMINER'S APPROVAL OF DRAWING CHANGES

Commissioner for Patents Washington, DC 20231

Dear Sir:

Submitted herewith is one set (one sheet, one figure) of corrected drawings for filing in the above-identified patent application.

The Examiner objected to the drawings for reasons stated in the Office Action (Paper No. 6) dated June 19, 2002. Specifically, Figure 3 was objected to because it did not include a label such as "related art". The enclosed new drawings correct these informalities.

Favorable consideration of the enclosed drawings is respectfully requested.

Dated: September 18, 2002

Respectfully submitted,

Teresa M. Arroyo

Registration No.: 50,015

MCKENNA LONG & ALDRIDGE LLP

1900 K Street, N.W.

Washington, DC 20006

(202) 496-7500

Attorneys for Applicant

